



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.	:	10/685,004
Applicant	:	S. Zaidi et al.
Filed	:	October 15, 2003
TC/A.U.	:	2818
Examiner	:	HO, Tu Tu V.
Docket No.	:	0928.0064C
Customer No.	:	054500
Confirmation No.	:	4281
Title	:	Mask and Method for Using the Mask in Lithographic Processing

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the Office Action mailed September 29, 2005, please amend the above-identified application as follows:

**Amendments to the Claims:** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks:** begin on page 6 of this paper.